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**EE C247B - ME C218**  
**Introduction to MEMS Design**  
**Spring 2014**

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**Lecture Module 11: Equivalent Circuits I**

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**Lecture Outline**

- Reading: Senturia, Chpt. 5
- Lecture Topics:
  - ↗ Lumped Mass
  - ↗ Lumped Stiffness
  - ↗ Lumped Damping
  - ↗ Lumped Mechanical Equivalent Circuits
  - ↗ Electromechanical Analogies

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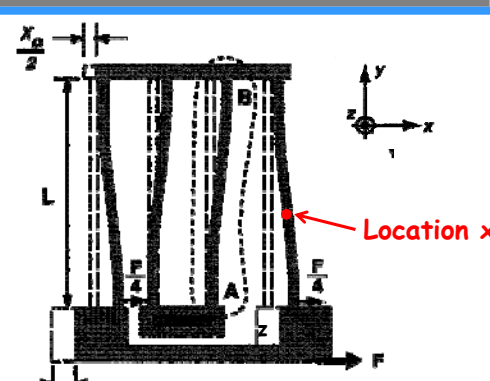
## Lumped Parameter Mechanical Equivalent Circuit

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## Equivalent Dynamic Mass

- Once the mode shape is known, the lumped parameter equivalent circuit can then be specified
- Determine the equivalent mass at a specific location  $x$  using knowledge of kinetic energy and velocity



Maximum Kinetic Energy  $\rightarrow$   $\frac{1}{2} \rho A \int_0^L v^2(x) dx$

Equivalent Mass =  $M_{eqx} = \frac{K.E.}{\frac{1}{2} v_x^2} = \frac{\frac{1}{2} \rho A \int_0^L v^2(x) dx}{\frac{1}{2} v_x^2}$

Maximum Velocity @ location  $x \rightarrow \frac{1}{2} v_x^2$       Maximum Velocity Function  $\rightarrow \frac{1}{2} v^2(x)$

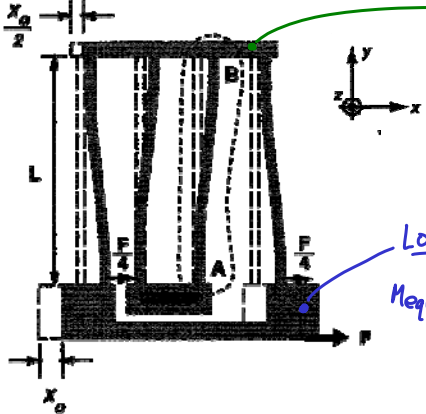
Density  $\rightarrow \rho$

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### Equivalent Dynamic Mass

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- For the folded-beam structure, we've already determined the maximum kinetic energy
- And in our resonance frequency analysis, we've already determined expressions for velocity



**Location on the Truss:**

$$M_{eq(truss)} = \frac{KE_{max}}{\frac{1}{2} V_{truss}^2} = \frac{\omega_0^2 x_0^2 (\frac{L}{2}) [M_s + \frac{1}{4} M_t + \frac{12}{35} M_b]}{\frac{1}{2} (\frac{L}{2}) \omega_0^2 x_0^2}$$

$$\therefore M_{eq(truss)} = 4 [M_s + \frac{1}{4} M_t + \frac{12}{35} M_b]$$

**Location on the Shuttle:**

$$M_{eq(shuttle)} = \frac{KE_{max}}{\frac{1}{2} V_{shuttle}^2} = \frac{\omega_0^2 x_0^2 (\frac{L}{2}) [M_s + \frac{1}{4} M_t + \frac{12}{35} M_b]}{\frac{1}{2} \omega_0^2 x_0^2}$$

$$\therefore M_{eq(shuttle)} = M_s + \frac{1}{4} M_t + \frac{12}{35} M_b$$

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### Equivalent Dynamic Stiffness & Damping

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- Stiffness then follows directly from knowledge of mass and resonance frequency

$$\omega_0 = \sqrt{\frac{K_{eq}(x)}{M_{eq}(x)}} \rightarrow K_{eq}(x) = \omega_0^2 M_{eq}(x) \quad \begin{array}{l} \text{= large equiv. mass \& } \\ \text{large stiffness go} \\ \text{hand-in-hand} \end{array}$$

- And damping also follows readily from knowledge of Q or other loss measurands

$$Q = \frac{\omega_0 M_{eq}(x)}{C_{eq}(x)} \rightarrow C_{eq}(x) = \frac{\omega_0 M_{eq}(x)}{Q} = \frac{\sqrt{K_{eq}(x) M_{eq}(x)}}{Q}$$

↑  
damping

- With mass, stiffness, and damping  $\Rightarrow$  lumped parameter equivalent circuit

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### Get Potential Energy & Frequency

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**Folded-beam suspension**  $Q = 100k$   
 Dimensions:  $60\mu m$ ,  $2\mu m$ ,  $L = 100\mu m$   
 Thickness:  $h = 2\mu m$

**Shuttle w/ mass  $M_s$**   
 Area:  $4,000\mu m^2$

**Folding truss w/ mass  $M_t/2$**

**Anchor**  $h = \text{thickness} = 2\mu m$

**Equivalent Circuits:**

- Truss:**  $K_{eq(truss)} = 19.2 \text{ N/m}$ ,  $M_{eq(truss)} = 8.64 \times 10^{-11} \text{ kg}$ ,  $C_{eq(truss)} = 4.08 \times 10^{-10} \text{ kg/s}$
- Shuttle:**  $K_{eq(shuttle)} = 4.8 \text{ N/m}$ ,  $M_{eq(shuttle)} = 2.16 \times 10^{-11} \text{ kg}$ ,  $C_{eq(shuttle)} = 1.02 \times 10^{-10} \text{ kg/s}$

*Handwritten notes:*  $K_{eq} = M_{eq} = C_{eq} = \infty$

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### Electromechanical Analogies

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**Mechanical System:**  $m_{eq}$ ,  $k_{eq}$ ,  $C_{eq}$ ,  $F(t)$ ,  $x(t)$

**Electrical Circuit:**  $I_x$ ,  $C_x$ ,  $r_x$ ,  $N$  (voltage),  $i = q$  (charge)

**Equation of Motion:**  
 $F(t) = F \cos(\omega t) \rightarrow x(t) = X \cos \omega t$   
 $m_{eq} \ddot{x} + C_{eq} \dot{x} + k_{eq} x = F(t)$

**Using phasor concepts:**  
 $F = j\omega m_{eq} \dot{x} + \frac{k_{eq}}{j\omega} x + C_{eq} \dot{x}$

**Impedance looking in:**  
 $\frac{N}{i} = j\omega l_x + \frac{1}{j\omega c_x} + r_x$   
 $N = j\omega l_x i + \frac{(1/C_x)}{j\omega} i + r_x i$

**Parameter Relationships in the Current Analogy:**

$F \rightarrow N$	$m_{eq} \rightarrow l_x$	$C_{eq} \rightarrow r_x$
$\dot{x} \rightarrow i$	$k_{eq} \rightarrow \frac{1}{C_x}$	

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### Electromechanical Analogies (cont)

• Mechanical-to-electrical correspondence in the current analogy:

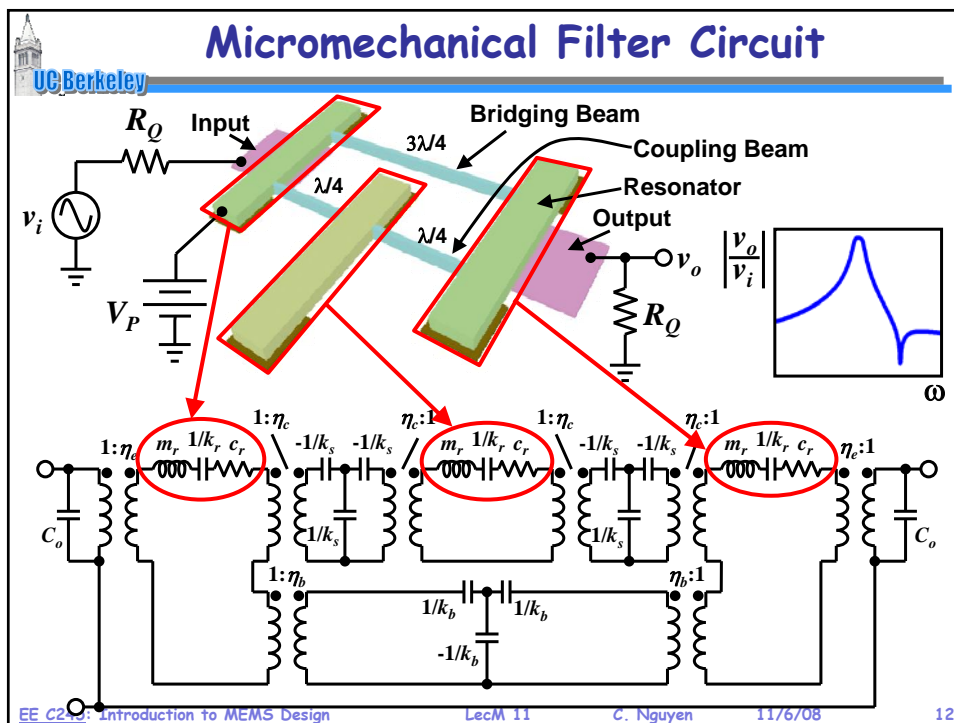
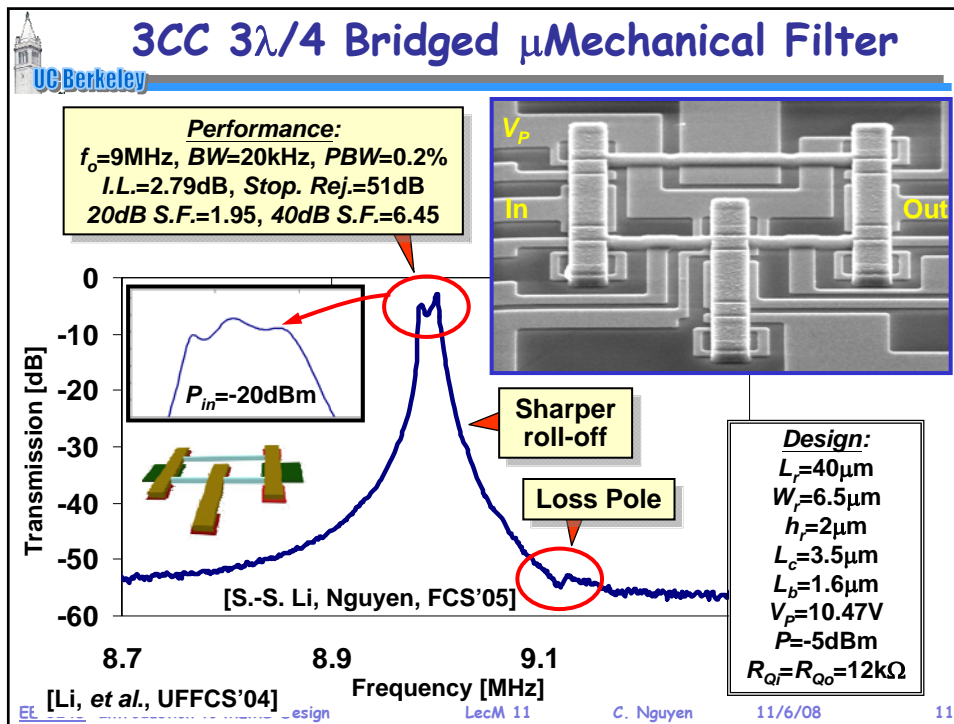
Mechanical Variable	Electrical Variable
Damping, $c$	Resistance, $R$
Stiffness <sup>-1</sup> , $k^{-1}$	Capacitance, $C$
Mass, $m$	Inductance, $L$
Force, $f$	Voltage, $V$
Velocity, $v$	Current, $I$

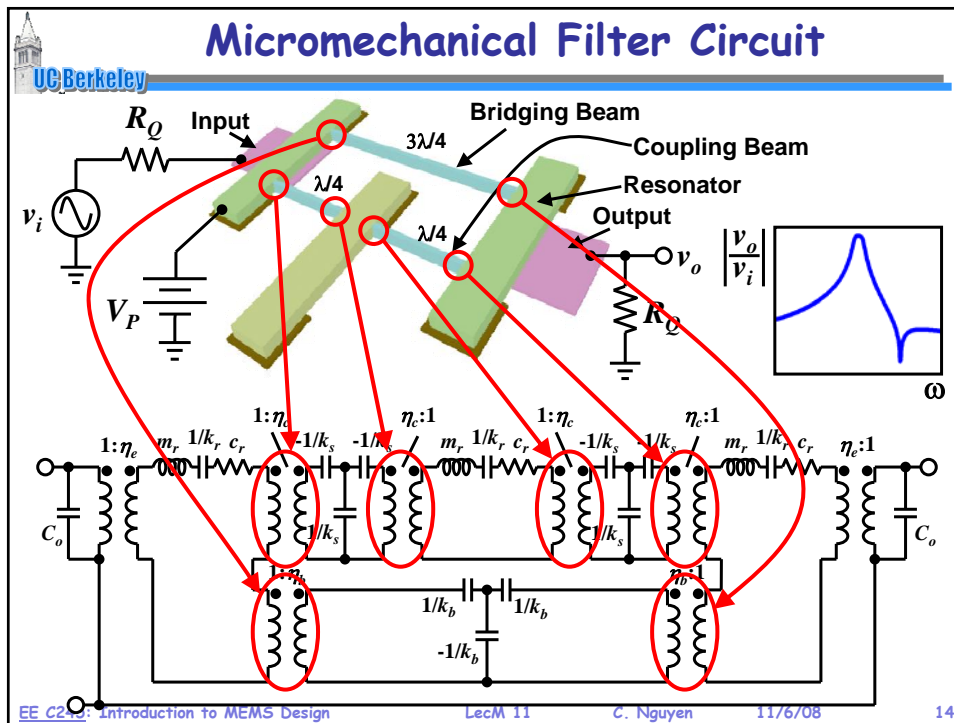
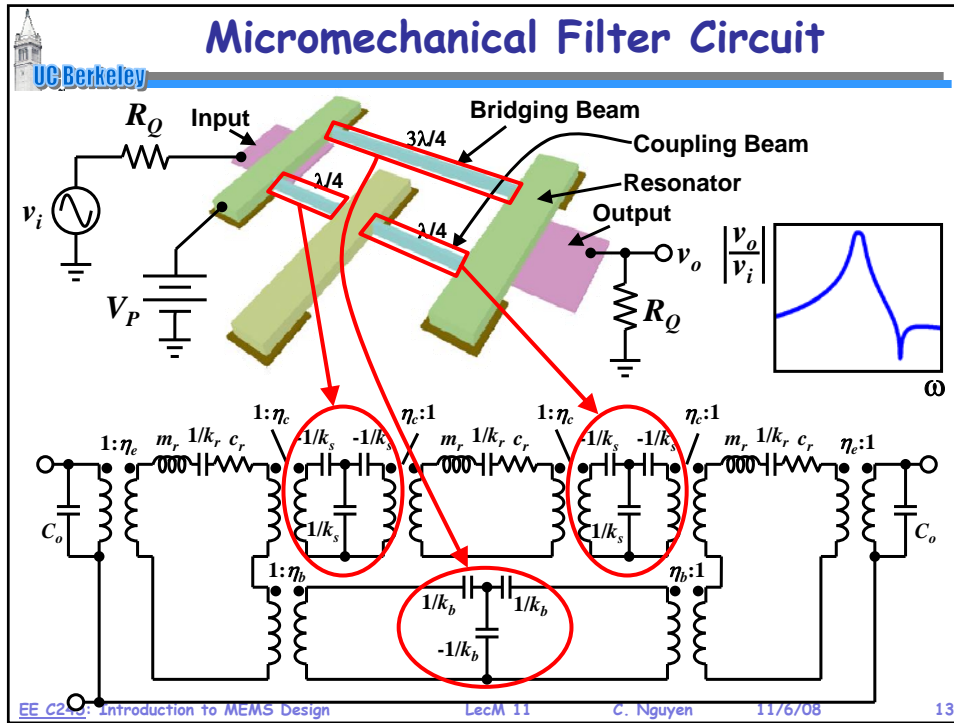
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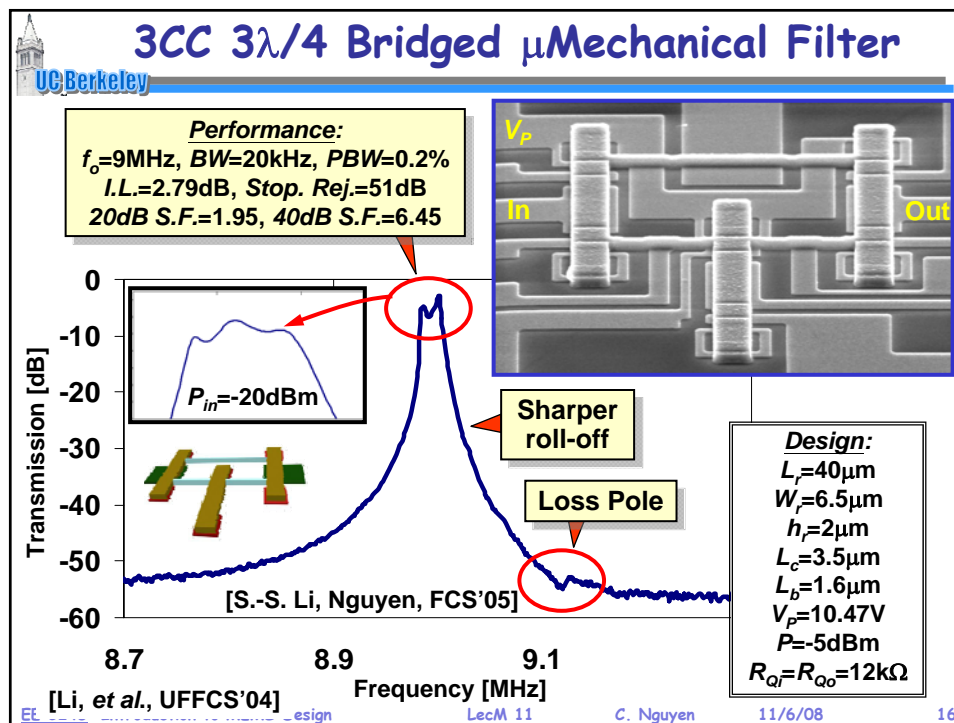
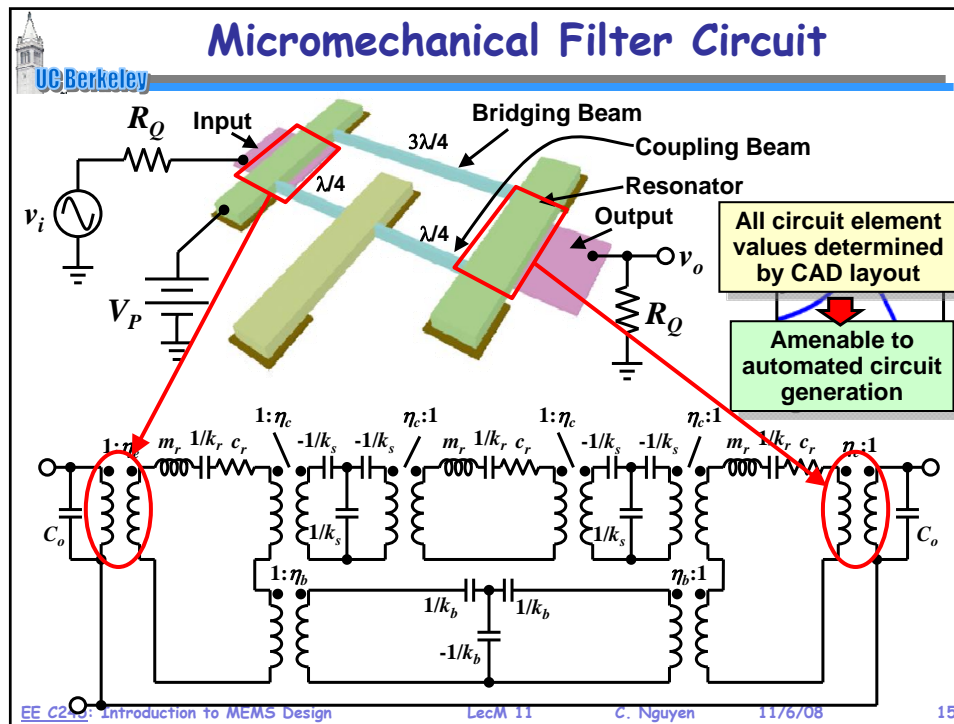
### Bandpass Biquad Transfer Function

$F = j\omega m_{eq} \dot{x} + \frac{k_{eq}}{j\omega} x + c_{eq} \dot{x}$   
 $\Rightarrow$  converting to full phasor form:  
 $F = (j\omega)(j\omega x) m_{eq} + \frac{k_{eq}}{j\omega} x + c_{eq} (j\omega x)$   
 $\frac{X}{F}(j\omega) = \frac{1}{k_{eq}} \left[ -\omega^2 \frac{m_{eq}}{k_{eq}} + 1 + j \frac{c_{eq}\omega}{k_{eq}} \right]^{-1} = \frac{1}{k_{eq}} \left[ -\left(\frac{\omega}{\omega_0}\right)^2 + 1 + j \frac{\omega}{Q\omega_0} \right]^{-1}$   
 $\left[ \frac{k_{eq}}{m_{eq}} = \omega_0^2, Q = \frac{m_{eq}\omega_0}{c_{eq}} = \frac{k_{eq}}{\omega_0 c_{eq}} \rightarrow \frac{k_{eq}}{c_{eq}} = Q\omega_0 \right]$


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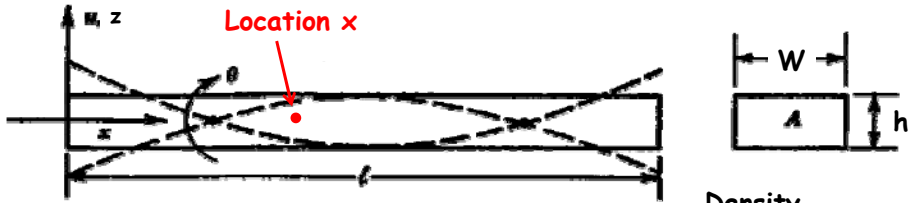
## Beam Resonator Equivalent Circuits (Pretty Much the Same Stuff)

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## Equivalent Dynamic Mass

- Once the mode shape is known, the lumped parameter equivalent circuit can then be specified
- Determine the equivalent mass at a specific location  $x$  using knowledge of kinetic energy and velocity



Maximum Kinetic Energy  $\rightarrow$   $\frac{1}{2} \rho A \int_0^l v^2(x) dx$   
 Equivalent Mass =  $M_{eq\ x} = \frac{K.E.}{\frac{1}{2} v_x^2} = \frac{\frac{1}{2} \rho A \int_0^l v^2(x) dx}{\frac{1}{2} v_x^2}$   
 Maximum Velocity @ location  $x$   $\rightarrow$   $\frac{1}{2} v_x^2$       Maximum Velocity Function  $\rightarrow$   $\frac{1}{2} v^2(x)$

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### Equivalent Dynamic Mass

• We know the mode shape, so we can write expressions for displacement and velocity at resonance

Displacement:  $u(x) = B \left[ S(\cosh kx + \cos kx) + (\sinh kx + \sin kx) \right], S = \frac{A}{B}$

$[V(x) = \omega u(x)] \Rightarrow M_{eq}(x) = \frac{KE_{max}}{\frac{1}{2}[V(x)]^2} = \frac{\frac{1}{2} \rho A \int_0^l \omega^2 [u(x')]^2 dx'}{\frac{1}{2} \omega^2 [u(x)]^2}$

$$M_{eq}(x) = \frac{\rho A \int_0^l B^2 [S(\cosh kx' + \cos kx') + (\sinh kx' + \sin kx')]^2 dx'}{B^2 [S(\cosh kx + \cos kx) + (\sinh kx + \sin kx)]^2}$$

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### Equivalent Dynamic Stiffness & Damping

• Stiffness then follows directly from knowledge of mass and resonance frequency

$$\omega_0 = \sqrt{\frac{K_{eq}(x)}{M_{eq}(x)}} \rightarrow K_{eq}(x) = \omega_0^2 M_{eq}(x)$$

• And damping also follows readily

$$Q = \frac{\omega_0 M_{eq}(x)}{C_{eq}(x)} \rightarrow C_{eq}(x) = \frac{\omega_0 M_{eq}(x)}{Q} = \frac{\sqrt{K_{eq}(x) M_{eq}(x)}}{Q}$$

$\uparrow$  damping

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**Equivalent Lumped Mechanical Circuit**

$K_{eq}(x) = \omega_o^2 M_{eq}(x)$

$M_{eq}(x) = \frac{\rho A \int_0^l [u(x')]^2 dx'}{[u(x)]^2}$

$C_{eq}(x) = \frac{\omega_o M_{eq}(x)}{Q}$

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**Equivalent Lumped Mechanical Circuit**

**Example:** Polysilicon w/  $l=14.9\mu\text{m}$ ,  
 $W=6\mu\text{m}$ ,  $h=2\mu\text{m} \rightarrow 70\text{ MHz}$

$K_{eq}(\text{node}) = \infty$   
 $M_{eq}(\text{node}) = \infty$   
 $C_{eq}(\text{node}) = \infty$

$K_{eq}(0) = 19,927\text{ N/m}$   
 $M_{eq}(0) = 1.03 \times 10^{-13}\text{ kg}$   
 $C_{eq}(0) = 5.66 \times 10^{-9}\text{ kg/s}$

$K_{eq}(l/2) = 53,938\text{ N/m}$   
 $M_{eq}(l/2) = 2.78 \times 10^{-13}\text{ kg}$   
 $C_{eq}(l/2) = 1.53 \times 10^{-8}\text{ kg/s}$

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